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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



re application of

: Confirmation No. 5731

Akihisa HONGO et al.

: Docket No. 2001\_0133A

Serial No. 09/762,582

: Group Art Unit 1753

Filed April 12, 2001

: Examiner Brian Mutschler

SUBSTRATE PLATING  
METHOD AND APPARATUS

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of  
May 7, 2003.

The fee of \$950.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion  
which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

10/29/2003 KBETEMAI 00000029 09762582

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By

A handwritten signature in dark ink, appearing to read "David M. Ovedovitz".

David M. Ovedovitz  
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October 27, 2003